

Piezo Flexure Actuators and Other Novel Piezo Mechanisms for Precision Motion Control Applications

Flexure-guided and motion-amplified actuators provide convenience and performance for the OEM designer. Piezo motors expand the motion range.

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Piezo actuators, a special form of electro-ceramics, are the gold standard when it comes to precision, speed, and force in a small package. To make them more accessible for the OEM designer, manufacturers package the actuators inside an arrangement of flexures providing precision guidance and amplified motion along with a simple mounting interface. Flexures are usually made of aluminum, steel or titanium. With the absence of friction and wear, they can provide billions of cycles of maintenance-free service.



PICMA® Ceramic encapsulated multilayer piezo stack are at the heart of the latest piezo flexure motion systems. Spherical tips facilitate integration.

At the heart of piezoelectric flexure actuators is a stack of layers of specialized ceramic, only a few dozen microns thick, interleaved with electrodes, and sintered into a solid structure. The most common piezo ceramic for high-performance positioning applications is PZT (lead-zirconate-titanate), a ferroelectric ceramic. This material is useful for positioning because PZT ceramic exhibits a small, but almost linear dimensional change as voltage is applied across the electrodes. This provides a precise, controllable motion input to the engineer's mechanism. Position

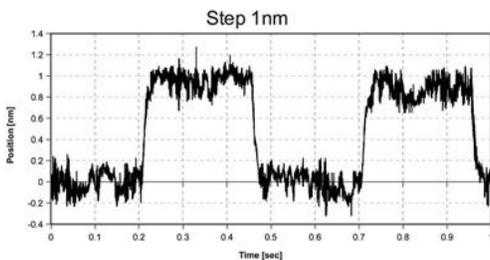
changes on the order of nanometers can be achieved without difficulty.

Why Use Piezo?

The operation of the piezo ceramic element is characterized by four factors: a) precision; b) speed; c) short travels; and d) high force.

The stack's positioning precision comes from its almost-linear dimensional change, which is free of stiction effects and can allow controllability down to the sub-nanometer range. This is why piezoelectric mechanisms are at the heart of today's semiconductor lithography tools, atomic-force microscopes, and the other nanoscale-precision systems.

Its speed comes from the solid-state actuation of the stack, which propagates at the speed of sound through the material, yielding responsiveness into the kHz region, with correspondingly impressive force capability. The speed of sound actuation also means that piezo actuators can respond to an input in microseconds, a feature that makes them suitable to applications such as valve control and nano-dosing where nanometer precision is only infrequently of secondary importance.



Precision is one of the reasons to chose a piezo flexure guided positioning system. The graph above shows crisp, repeatable sub-nanometer step response of a [P-630 miniature flexure-guided nanopositioning stage](#), measured with Zygo laser interferometer.

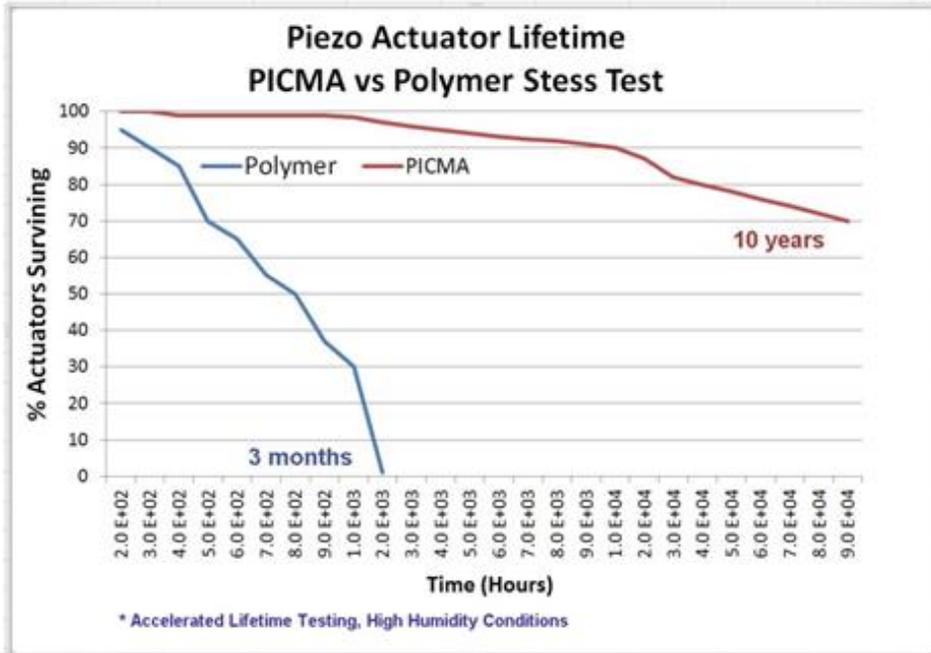
Its travel limitation comes from the maximum strain the actuators can achieve, typically about 1 percent of their length. Consequently, piezoelectric flexure actuators utilize frictionless lever amplifiers that magnify the actuator motion. Clever design means motion ranges of up to 2mm can be achieved in compact packages.



[Animation – piezo flexure drives explained](#)

Until recently, piezoelectric flexure actuators have mostly been employed inside specialized piezoelectric stages for ultra-precision positioning applications and were not easily available to the OEM mechanical engineer. That has changed, and flexure actuators with long travels are now available as off-the-shelf items for ready integration into custom mechanisms. This new accessibility has opened the door for a wide variety of specialized mechanisms across a broad spectrum of industries.

Ease of Use and Cost Effectiveness



The latest generation multilayer piezo actuators are based on all-ceramic designs. They can handle high humidity environments, unlike their conventionally polymer insulated siblings.

Central to the utility of piezoelectric flexure actuators is their range of configurations and their well-thought-out mounting provisions. These are easy mechanisms to integrate into a design. Everything has been considered: their integrated preload mechanisms accommodate even high-dynamic actuation; their optional position sensors are pre-aligned and reproducible; their flexure guidance accommodates common applications without difficulty. A wide range of controllers are available, spanning the spectrum of capability and cost. Some feature the latest communications interfaces, internal waveform-generation capability, all-digital servo-controlled including trimpot-free calibration, and integrated data-collection options, all in cost-effective, OEM-friendly configurations.



OEM board-level piezo driver (left) and E-709 digital servo closed-loop piezo controller shown with a piezo flexure positioning stage for microscopy applications.

Broad Choices, New Options

The new piezoelectric flexure actuators complement and extend the existing portfolio of form-factors and packaging styles for piezoelectric actuators. Ceramic stacks – with or without integrated position sensors – have traditionally been available to engineers wishing to perform all integration.

Packaged actuators have commonly been used for applications needing easy mounting and integral low-stiction preloads for dynamic actuation.

The new breed of fully integrated flexure actuators now offer preconfigured subassemblies which integrate stictionless lever amplification as well as preload elements and optional position feedback. Thus, piezoelectric flexure actuators offer especially easy mounting for the greatest convenience and performance for research and OEM applications, and they require the least specialized engineering to design-in and implement.

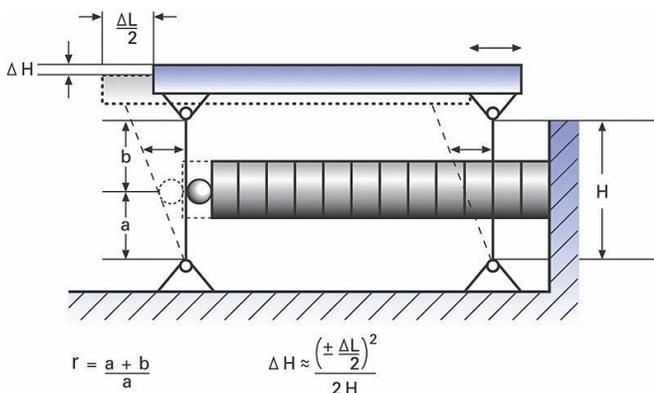


[Piezo flexure amplified actuators](#) in different customization levels, from low-cost OEM actuators suited to drive micro-pumps to complete [closed-loop nano-focus positioning systems](#).

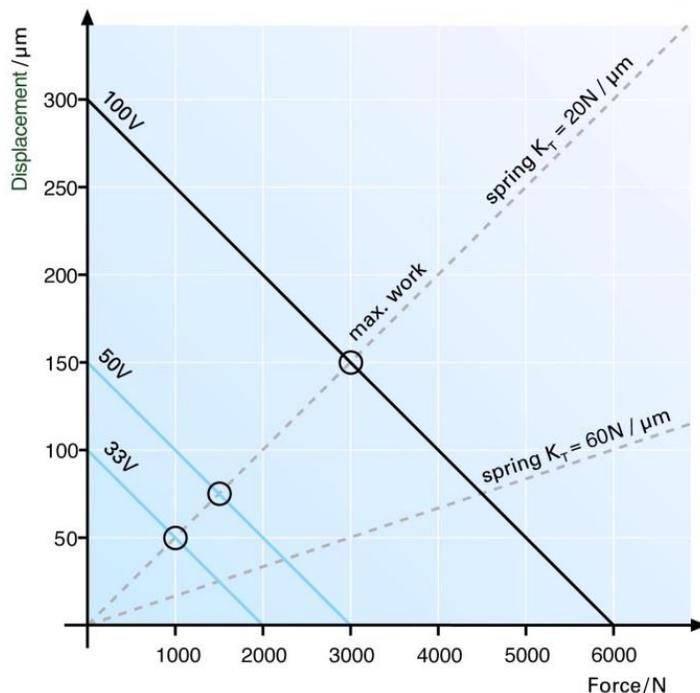
All of these choices share the common benefits of piezoelectric actuators, such as nanoscale precision, high speed and force, solid-state and lubricant-free actuation, non-magnetic and field-free operation, and vacuum compatibility.

Travel vs. Force Generation

Piezo flexure actuators are used for precision positioning, as well as for moving things quickly, and for force generation. Force generation usually means pushing against an external elastic material.



Piezo flexure actuator with a simple parallelogram flexure guiding system and motion amplifier. The amplification r (transmission ratio) is given by $(a+b)/a$.



Force generation vs. displacement of an ideal piezo actuator (displacement 300 μm, stiffness 20 N/μm) working against an external spring. The points where the dashed lines (external spring curves) intersect the piezo actuator force/displacement curves determine the force and displacement for a given setup with an external spring. The stiffer the external spring (flatter dashed line), the less the displacement and the greater the force generated by the actuator. Maximum work is generated when the stiffness of the piezo actuator and external spring are matched.

As the diagram shows, working against a load reduces the available travel of an actuator, according to a simple formula:

$$F_{\text{max eff}} \approx k_T \cdot \Delta L_0 \left(1 - \frac{k_T}{k_T + k_S} \right)$$

Effective force that a piezo actuator can generate in a yielding restraint, where:

L_0 = max. nominal displacement without external force or restraint (m)

k_T = piezo actuator stiffness (N/m)

k_S = stiffness of external spring (N/m)

Stiffness, Responsiveness

The additional motion provided by flexure-amplified piezo actuators does, however, come at a price. With increasing amplification ratio, both stiffness and responsiveness are reduced. Nevertheless, well designed piezo flexure actuators can still provide sub-millisecond step-and-settle times, significantly faster than any other conventional actuator.

The following relations apply to (ideal) motion amplifiers for any primary drive system:

$$k_{\text{sys}} = \frac{k_0}{r^2} \quad \Delta L_{\text{sys}} = \Delta L_0 \cdot r \quad f_{\text{res-sys}} = \frac{f_{\text{res-0}}}{r}$$

In this formula:

r = motion amplifier ratio

L_0 = travel of the primary drive (m)

L_{sys} = travel of the lever-amplified system (m)

k_{sys} = stiffness of the lever-amplified system (N/m)

k_0 = stiffness of the primary drive system (piezo stack and joints) (N/m)

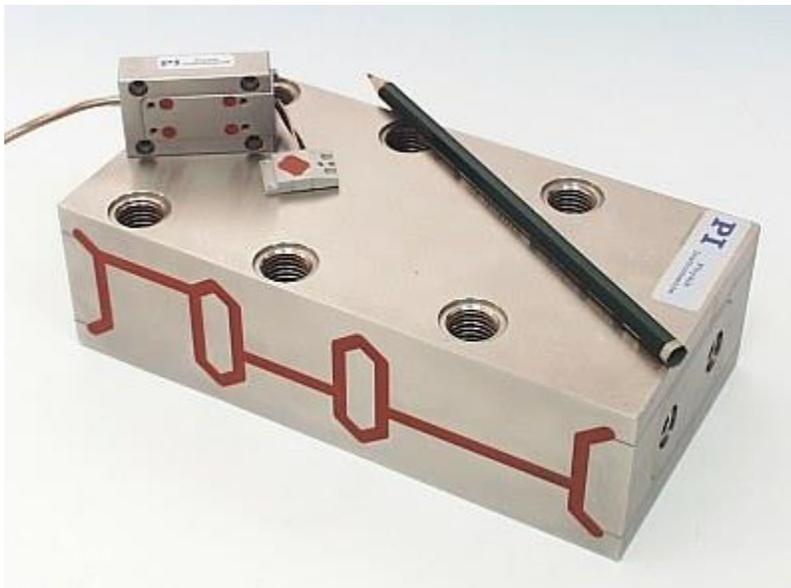
f_{res-0} = resonant frequency of the primary drive system (piezo stack and joints) (Hz)

$f_{res-sys}$ = resonant frequency of the amplified system (Hz)

Resonant frequency is directly proportional to the responsiveness of the system.

Custom Actuators: No One-Size-Fits-All Solution

With the variety of parameters, such as size, force, precision, travel range and cost, it is obvious that one flexure actuator cannot fit all applications. Often, a standard part may come close enough to be integrated in a prototype, however, for optimized cost and performance, it usually pays off for the OEM mechanical system engineer to work closely with an experienced piezo mechanism manufacturer. Prototypes of custom designs can be prepared within as little as a few weeks.



Custom flexure positioners in different sizes for different load and force generation. Piezo-flexure drives are used for applications from fiber-optics alignment to precision machining.

Mars Mission: 100 Billion Cycles of Lifetime

Regardless of the form-factor, the latest designs of piezoelectric actuators are very reliable mechanisms. They must be, since they are the mission-critical heart of so many industrial and research applications, ranging from semiconductor fabrication to atomic-force microscopy. After all, they are structurally quite similar to ceramic capacitors, which are ubiquitous in electronics. However, they can be sensitive to humidity. Previously, PZT stacks were encapsulated by painting them with a polymer coating. This provided a small amount of protection against infiltration by ambient water vapor. Far more effective is the patented construction of PICMA[®] model actuators – developed by Physik Instrumente (PI), which has played a pioneering role in advancing the

development of piezo devices – incorporating a hermetic ceramic coating and many subtle design details which ensure long life, even in the presence of high humidity. PICMA stacks are used in all PI flexure actuators.

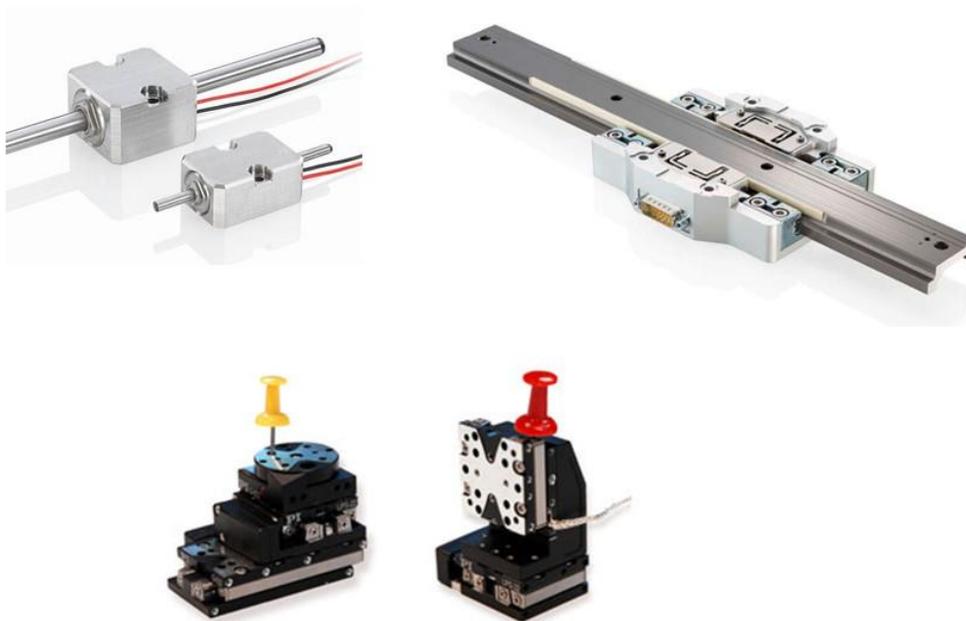
The solid state, frictionless design means wear and tear is not an issue when it comes to lifetime. Recent tests for space qualification of PICMA actuators have shown that even after 100 billion cycles the actuator performance only dropped by a few percentage points. See www.ncbi.nlm.nih.gov/pubmed/21507759.

These actuators are now used in the Mars Science Laboratory on the Curiosity rover’s ChemIn particle analyzer instrument. See <http://msl-scicorner.jpl.nasa.gov/Instruments/CheMin/>.

Expanding the Spectrum of Piezoelectric Motion

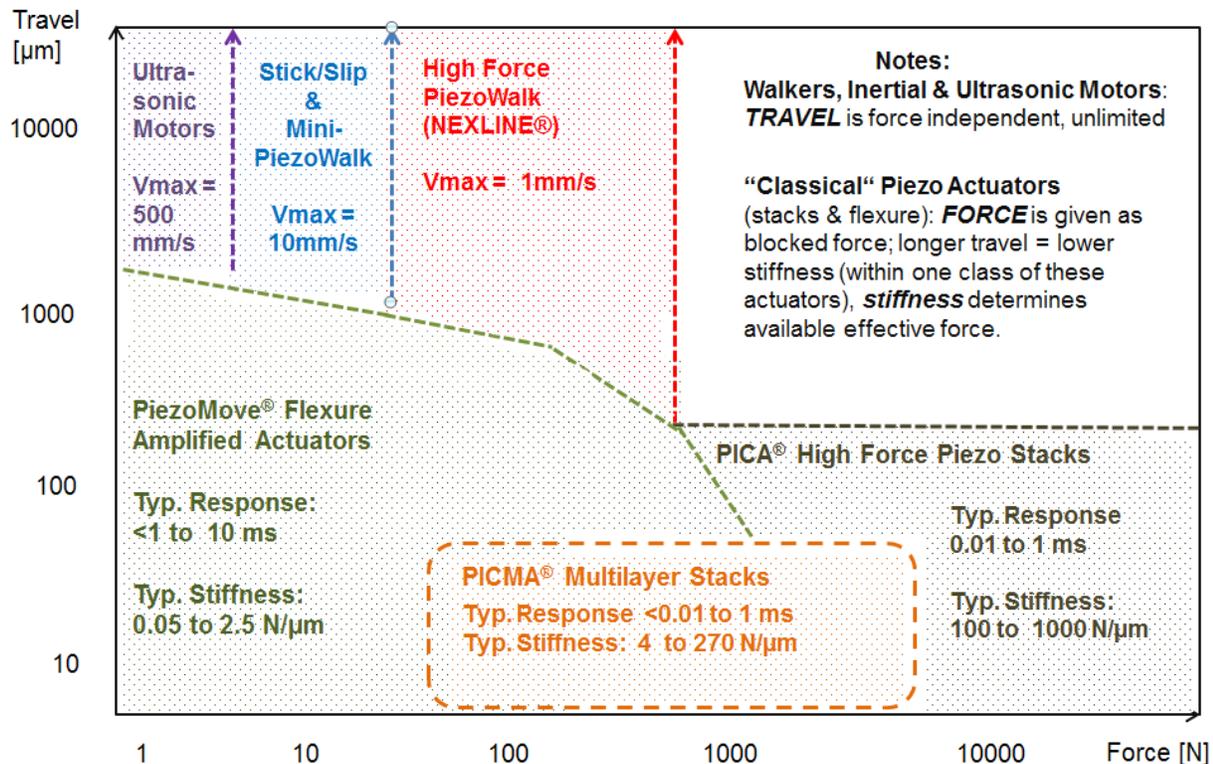
Piezoelectric flexure actuators are but one utensil in a deep toolbox of motion technologies driven by piezoelectric principles, which include:

- Piezo ceramic stacks
- Packaged, preloaded stack piezo actuators
- Piezo flexure actuators
- Piezo linear motors with long travels and nanoscale position-hold stability
 - A. Walking motors for high push/pull and holding force
 - B. Ultrasonic resonant motors for high speeds
 - C. Incrementing inertial motors (stick/slip) for low cost and minimized dimensions



Different piezo motor driven actuators provide long travel ranges to 100’s of mm’s: inertia-type mini-rod actuators (top left), ultrasonic, high-speed actuator (top right) and Q-motion series miniaturized multi-axis stick-slip motor stages (bottom)

All Piezo Motors are NOT Created Equal: Force, Velocity, Travel



Comparison of force, speed, and travel capabilities of different piezo-based drive systems

Summary

Piezoelectric flexure drives offer unmatched ability to drop into a custom assembly and provide fast, precise actuation without fuss and bother, and with demonstrated reliability to extend into the many billions of cycles.

Recently-introduced piezo-motor technologies expand the use of piezo motion into long travel applications.

Piezoelectric devices are increasingly being utilized by product designers and incorporated successfully into a widening range of applications where precision motion control is needed. These devices are compact, require low voltage, deliver high torque, exhibit short response time, generate little heat, are both nonmagnetic and vacuum compatible, and have few mechanical component parts to wear out and service.

The latest generation of piezo mechanisms delivers an even broader product development capability for OEM designers.